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PATENT
2091-0205P

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant: Nobuyoshi NAKAJIMA Conf.: 3582

Appl. No.: 09/447,256 Group: 2623

Filed: November 23, 1999 Examiner: C. LAROSE

For: IMAGE PROCESSING METHOD AND APPARATUS

STATEMENT OF THE SUBSTANCE OF THE INTERVIEWCommissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

December 23 2003

RECEIVED

DEC 24 2003

Technology Center 2600

This statement of the Substance of the Interview is being filed in accordance with MPEP §713.04.

Applicant's representative conducted a personal interview with the Examiner, Colin LaRose, and the Primary Examiner, Amelia Au, on December 11, 2003. During the interview, the combination of Kobori et al. and Kado et al. was discussed, in particular Applicant's representative argued that one skilled in the art would not look towards Kado et al. to make up for the deficiencies of Kobori et al. An agreement, however, was not reached.

If necessary, the Commissioner is hereby authorized in this, concurrent, and future replies, to charge payment or credit any overpayment to Deposit Account No. 02-2448 for any additional fees

required under 37 C.F.R. §§ 1.16 or 1.17; particularly, extension of time fees.

Respectfully submitted,

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By


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